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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2811  
Examiner: Unassigned

In Re PATENT APPLICATION Of:

Applicant(s): Noriyuki MIURA

Serial No.: 10/690,579

Filed: October 23, 2003

For: SEMICONDUCTOR DEVICE AND  
METAL-OXIDE-SEMICONDUCTOR  
FIELD-EFFECT TRANSISTOR

Atty Ref.: MAE 296

)  
)  
) **INFORMATION**  
) **DISCLOSURE**  
) **STATEMENT AND**  
) **CERTIFICATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is an Information Disclosure Statement submitted in compliance with the timing requirements of 37 C.F.R. § 1.97(b)(3), i.e., prior to a First Office Action on the merits.

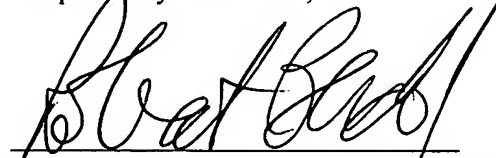
Attached are copies of two Japanese patent publications, which were cited in the attached Japanese Office Action dated June 15, 2004, and from which any relevance of the publications may be gleaned. The Action was issued by the Japanese Patent Office in connection with a Japanese counterpart application and discusses these publications. Also attached are English-language abstracts of the publications, from which any further relevance of the documents may be gleaned. Also attached is a copy of one European patent application publication, which is a counterpart of the Japanese patent publication No. 7-162011 (one of the two above-mentioned publications). Any relevance of the

European patent application publication is self-evident. The publications are listed on the attached Form PTO-1449.

It is hereby certified that each item of information contained in the Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Since this Information Disclosure Statement is being filed before a first office action on the merits, no fee is required, and the requirements of 37 C.F.R. §§ 1.97 and 1.98 are deemed to be fully met as to all listed documents. Consideration of the listed documents is respectfully requested.

Respectfully submitted,

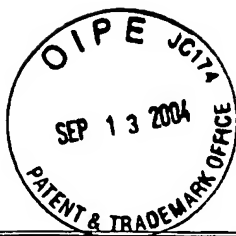


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September 13, 2004  
Date

RHB:vm

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<b>FORM PTO-1449</b> <b>INFORMATION DISCLOSURE STATEMENT</b>		Atty. Docket  MAE 296		Application No.  10/690,579			
		Applicant Noriyuki MIURA					
		Filing Date October 23, 2003		Group 2811			
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
<b>FOREIGN PATENT DOCUMENTS</b>							
		Document Number	Date	Country	Class	Sub-Class	Translation
	AI	5-235350	09/10/93	JAPAN			Abstract
	AJ	7-162011	06/23/95	JAPAN			Abstract
	AK	650 190 A1	04/26/95	EUROPE			N/A
	AL						
	AM						
	AN						
<b>OTHER (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AO						
Examiner					Date Considered		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							